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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Kenichi SHIRAI SHI

Serial No: 10/589,437

Group Art Unit: 2882

Confirmation No. 9870

Filed: August 1, 2007

Examiner: ASFAW, MESFIN T

For: EXPOSURE APPARATUS, SUPPLY METHOD AND RECOVERY METHOD,  
EXPOSURE METHOD, AND DEVICE PRODUCING METHOD

**COMMUNICATION TO THE EXAMINER**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

An Information Disclosure Statement with Form PTO-1449 was filed on May 25, 2011, as evidenced by the USPTO PAIR image file wrapper (IFW). A copy of the Examiner initialed and signed Forms PTO-1449 has not been received by the undersigned.

It is respectfully requested that the Examiner return a copy of the **Form PTO-1449** accompanying the Information Disclosure Statement, signed and initialed to indicate that the references listed therein have been considered by the Office.

Since the application has been allowed, this matter is somewhat urgent.

Respectfully submitted,

STAAS & HALSEY LLP

Date: July 18, 2011

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